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2811

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: John T. Moore et al. § Group Art Unit: 2811
Serial No.: 09/496,794 §
Filed: February 2, 2000 §
For: Trench Isolation for §
Semiconductor Devices § Atty. Dkt. No.: MCT-0005-D1-US
97-0608

#15/D
And
J. Mancilla
9/11/02

Commissioner for Patents
Washington DC 20231

REPLY TO PAPER NO. 14

Sir:

In response to the office action mailed July 31, 2002, please amend the application as follows:

IN THE CLAIMS

Please cancel claims 31-34.

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REMARKS

The pending claims 26-30 were rejected under § 103 over the patent to Fazan that is assigned to Micron Technology, Inc. as is the present application. Moreover, the Fazan patent issued less than a year before the filing date of this application. Therefore under 35 U.S.C. § 103(c), the Fazan patent cannot be used to fashion a § 103 rejection of the present application. See M.P.E.P. § 2146.

Date of Deposit: August 21, 2002
I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, Washington DC 20231.
Cynthia L. Hayden
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